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TO

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **WATANABE, Kenichi**

Group Art Unit: 2815

Serial No.: 10/050,171

Examiner: **WARREN, Matthew E.**

Filed: **January 18, 2002**

P.T.O. Confirmation No.: 7623

**FOR: SEMICONDUCTOR DEVICE CAPABLE OF SUPPRESSING CURRENT
CONCENTRATION IN PAD AND ITS MANUFACTURE METHOD**

RESPONSE UNDER 37 CFR §1.116

**- EXPEDITED RESPONSE -
GROUP ART UNIT 2815**

MAILSTOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Okay to
Enter Amelt.
NEW 2/27/07

February 1, 2007

Sir:

In response to the Office Action dated **November 2, 2006**, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.